## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Satoshi KAMIYAMA et al.

Group Art Unit: 1722

Application Number: 10/500,002

Examiner: Matthew J. Song

Filed: November 16, 2004

Confirmation Number: 2766

For:

GROUP III NITRIDE SEMICONDUCTOR SUBSTRATE AND ITS

MANUFACTURING METHOD

Attorney Docket Number:

042398

Customer Number:

38834

October 23, 2007

## **AMENDMENT UNDER 37 CFR §1.116**

MAILSTOP: AF Commissioner for Patents

P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

This paper is filed in response to the Office Action dated July 23, 2007.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.